H-A

\$17 03CO

500.39825X00

MAY 1 700 B

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

licants:

T. HIROSE

erial No.:

09/800,495

Filed:

March 8, 2001

For:

METHOD OF DETECTING AND MEASURING ENDPOINT OF POLISHING PROCESSING AND ITS APPARATUS AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

USING THE SAME

Group:

(Not Yet Assigned)

Examiner:

(Not Yet Assigned)

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97 & 1.98

Assistant Commissioner For Patents Washington, D.C. 20231

May 11, 2001

Sir:

In the matter of the above-identified application, applicant is submitting herewith copies of the documents listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration.

This Information Disclosure Statement is being submitted before the mailing date of a first office action on the merits.

To the extent the documents listed on the attached form equivalent to Form PTO-1449 are not in the English language, the requirement of 37 CFR 1.98(a)(3) for a concise explanation of the relevance is satisfied by an English abstract thereof.

It is respectfully requested that this information disclosure statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Case: 500.39825X00), and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

Melvin Kraus

Registration No. 22,466

(703) 312-6600 Attachments

MK:pc